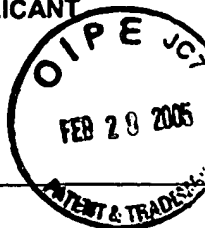


Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)



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Group Art Unit 2811
Examiner Name Unknown

Sheet 1 of 1

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